

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

MAEKAWA et al.)

Serial No.: 10/827,457)

Filed: April 19, 2004)

For: Method For Forming Pattern And
Drop Discharge Apparatus)

Examiner: Marianne L. Padgett)

Art Unit: 1762)

Confirm No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C (AFTER FINAL)

Applicants have the following response to the Final Rejection of July 6, 2007.

Please amend the above-identified application as follows: